



PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#21/E  
Filed  
4/15/03

In re application of:

Tzeng  
Serial No: 09/501,114  
Filed: February 10, 2000  
For: Method of Plasma Enhanced  
Chemical Vapor Deposition  
of Diamond

Group Art Unit: 1762  
Examiner: Wesley D. Markham  
Docket No.: 220101-1010

**PRELIMINARY AMENDMENT (RCE)**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In regard to the above-referenced application, the Applicant submits the following Preliminary Response and remarks to be respectively entered and considered with the accompanying request for continued examination (RCE).

**AUTHORIZATION TO DEBIT ACCOUNT**

It is not believed that extensions of time or fees for net addition of claims are required, beyond those, which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary to allow consideration of this paper, such extensions are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to deposit account no. 20-0778.

**CERTIFICATE OF MAILING (37 CFR 1.8)**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope to the: Assistant Commissioner For Patents, Washington, D.C. 20231.

*B Bryan*  
Jo Bryan  
Date: April 1, 2003

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